	Application No.	Applicant(s)	
A	09/773,664	YAMASHITA, TAKA	TOSHI
Notice of Allowability	Examiner	Art Unit	
	Mary A. El-Shammaa	2881	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in the operation of the operation of the appropriate communication is subjection in the communication in the in the comm	is application. If not include cation will be mailed in due	ed course. <b>THIS</b>
1. $igotimes$ This communication is responsive to <u>Response filed 15 N</u>	<u>farch 2004</u> .		
2. The allowed claim(s) is/are <u>1-6</u> .			
3. $\square$ The drawings filed on are accepted by the Examin	er.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority of a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have 2.  Certified copies of the priority documents have 3.  Copies of the certified copies of the priority documents have linternational Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	ve been received. ve been received in Application N	No	tion from the
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		reply complying with the red	quirements
5. A SUBSTITUTE OATH OR DECLARATION must be subr INFORMAL PATENT APPLICATION (PTO-152) which give			OTICE OF
6. ☐ CORRECTED DRAWINGS ( as "replacement sheets") mu  (a) ☐ including changes required by the Notice of Draftsper  1) ☐ hereto or 2) ☐ to Paper No./Mail Date  (b) ☐ including changes required by the attached Examiner  Paper No./Mail Date 0504.  Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	rson's Patent Drawing Review (  r's Amendment / Comment or in  1.84(c)) should be written on the o	the Office action of frawings in the front (not the	back) of
<ol> <li>DEPOSIT OF and/or INFORMATION about the dep attached Examiner's comment regarding REQUIREMENT</li> </ol>	OSIT OF BIOLOGICAL MATER FOR THE DEPOSIT OF BIOLO	IAL must be submitted. N DGICAL MATERIAL.	Note the
Attachment(s)  1.   Notice of References Cited (PTO-892)  2.   Notice of Draftperson's Patent Drawing Review (PTO-948)  3.   Information Disclosure Statements (PTO-1449 or PTO/SB. Paper No./Mail Date  4.   Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview Sum Paper No./Ma /08), 7. ⊠ Examiner's An	il Date	

Application/Control Number: 09/773,664 Page 2

Art Unit: 2881

## **DETAILED ACTION**

## **Drawings**

1. Figure 3 should be designated by a legend such as --Prior Art-- because only that which is old is illustrated. See MPEP § 608.02(g). A proposed drawing correction or corrected drawings are required in reply to the Office action to avoid abandonment of the application. The objection to the drawings will not be held in abeyance.

2. New corrected formal drawings are required in this application because Figure 2 has handwritten corrections.

## Allowable Subject Matter

- 3. Claims 1-6 are allowed.
- The following is an examiner's statement of reasons for allowance: The Examiner agrees with Applicant's arguments stating the deficiencies in the prior art to teach the relation in the claimed invention being satisfied. Regarding claims 1 and 4, the previously applied references (Maishev et al. US 6,037,717 and Bright et al. US 5,554,852), as well as the prior art, fail to teach or fairly suggest, in addition to the accompanying features of the claims, an ion source comprising a plasma production vessel which serves as an anode, a filament, a reflector, and a magnet wherein a relation  $L < 3.37B^{-1}\sqrt{(V_A)} \times 10^{-6}$  is satisfied where the distance from the center of the filament to the wall of the ion source is less than the Larmor radius of an electron. The Applicant teaches that by satisfying the above stated condition, the probability of a high energy electron colliding against the wall face of the ion source is increased, which shortens the

Art Unit: 2881

life span of the high-energy electrons and allows for the ratio of molecular ions in plasma to be enhanced.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. US 6,037,717, US 5,554,852, US 5,455,081, and US 4,743,804, all of which pertain to ion sources where the Larmor radius of ions and electrons are addressed.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Mary A. El-Shammaa whose telephone number is 571.272.2469. The examiner can normally be reached on M-F (8:30am-5:00pm).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R. Lee can be reached on 571.272.2477. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Application/Control Number: 09/773,664

Art Unit: 2881

Page 4

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

MAE May 19, 2004

NIKITA WELLS
PRIMARY EXAMINER 05/19/04